

DOCKET NO: 284901US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF	:	
HACHISHIRO IIZUKA	:	EXAMINER: KEATH T. CHEN
SERIAL NO: 10/565,676	:	
FILED: JANUARY 24, 2006	:	GROUP ART UNIT: 1792
FOR: GAS REACTION SYSTEM AND SEMICONDUCTOR PROCESSING APPARATUS	:	"RESPONSE UNDER 37 CFR 1.116- EXPEDITED PROCEDURE EXAMINING GROUP <u>1792</u> "

AMENDMENT UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS  
Alexandria, VA 22313

Sir:

In response to the Office Action of November 9, 2007, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.